

Practitioner's Docket No. 081468-0307112
Client Reference: P-0415.010-US



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **LEVINUS PIETER BAKKER**

Application No.: 10/743,270

Confirmation No.: 4454

Filed: December 23, 2003

Group No.: 2878

Examiner:

For: **LITHOGRAPHIC APPARATUS WITH DEBRIS SUPPRESSION,
AND DEVICE MANUFACTURING METHOD**

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

**SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76(c)**

The following information on the Application Data Sheet is changed as indicated:

BIBLIOGRAPHIC DATA

1. Assignee information is being modified.

The assignee(s) of this application is/are:

**ASML NETHERLANDS B.V.
De Run 6501, NL-5504 Veldhoven, The Netherlands
Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST**

Date: May 21, 2004

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